Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 22 May 2009

Message Text

UNCLASSIFIED

PAGE 01 PRETOR 01212 141447Z
ACTION COME-00

INFO OCT-01 AF-08 ISO-00 DODE-00 EB-08 NSAE-00 USIA-15
TRSE-00 ERDA-07 CIAE-00 OES-06 /045 W
----------141531Z 024216 /45
R 141406Z MAR 77
FM AMEMBASSY PRETORIA
TO SECSTATE WASHDC 7087
INFO AMCONSUL CAPE TOWN

UNCLAS PRETORIA 1212

CAPE TOWN FOR EMBASSY

E.O. 11652: N/A
TAGS: PINR, SF
SUBJECT: EXPORT CONTROL: SEMICONDUCTOR MANUFACTURING
EQUIPMENT

REF: STATE 28634

1. EMB OFFICER INSPECTED CSIR INTEGRATED CIRCUIT MANUFACTURING FACILITY MARCH 12 IN COMPANY OF CSIR DEPUTY PRESIDENT HEWITT AND DIRECTOR VAN WYK OF NATIONAL ELECTRICAL ENGINEERING RESEARCH INSTITUTE WITH VIEW TO REPORTING ON SAG PLANS AND CAPABILITIES IN THIS FIELD. HOWEVER WE WERE SUBSEQUENTLY ADVISED BY AFRONIX THAT WIRE BONDERS AND SCRIBING MACHINES MENTIONED PARA 2 OF REFTEL HAVE NOW BEEN LICENSED. UNLESS OTHERWISE INSTRUCTED, WE WILL NOT TAKE FURTHER ACTION.
BOWDLER

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NNN

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Message Attributes

Automatic Decaptioning: X
Capture Date: 01-Jan-1994 12:00:00 am
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: EXPORT CONTROLS, SEMICONDUCTOR DEVICES
Control Number: n/a
Copy: SINGLE
Sent Date: 14-Mar-1977 12:00:00 am
Decaption Date: 01-Jan-1960 12:00:00 am
Decaption Note:
Disposition Action: n/a
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment:
Disposition Date: 01-Jan-1960 12:00:00 am
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1977PRETOR01212
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: N/A
Errors: N/A
Expiration:
Film Number: D770087-0140
Format: TEL
From: PRETORIA
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1977/newtext/t19770362/aaaaccuu.tel
Line Count: 42
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 3f507bb8-c288-dd11-92da-001cc4696bcc
Office: ACTION COME
Original Classification: UNCLASSIFIED
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators: n/a
Previous Classification: n/a
Previous Handling Restrictions: n/a
Reference: 77 STATE 28634
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 04-Oct-2004 12:00:00 am
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 3117480
Secure: OPEN
Status: NATIVE
Subject: EXPORT CONTROL: SEMICONDUCTOR MANUFACTURING EQUIPMENT
TAGS: PINR, ELEC, SF
To: STATE
Type: TE
vdkvgwkey: odbc://SAS/SAS.dbo.SAS_Docs/3f507bb8-c288-dd11-92da-001cc4696bcc
Review Markings:
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